



Metzger, David R.

Exhibit G

From: Leah N. Tracy [Leah N. Tracy/CHI/SNR@SNR]
Sent: Thursday, May 01, 2003 4:31 PM
To: David R. Metzger
Cc: Karen A. Turkowski
Subject: Daily Due Dates and Reminders 5/3-5/5/03

Please find attached your list of items due for Saturday 5/3/03 thru Monday 5/5/03 in report form. Please notify Docket if you would like to extend or clear any dates.

Thank you!



dvm.pdf (32 KB)

Leah N. Tracy

Agency Intellectual Property and Technology Docket
Sonnenschein, Nath, and Rosenthal
312-876-7406
ltracy@sonnenschein.com

Thursday, May 01, 2003

Due Date List by Client

Page: 3

From 03-May-2003 To 05-May-2003

Client: 09798731 American Services Network, P.C.

Due Date/ Date Type	Reason for Date	Action Base Date/ Action Type	Client-Matter No	Matter Number	Ctry	Application Number	Filing Date	Confirm No.	Attys
03-May-2003 Reminder	1 Month to Response to OA	03-Mar-2003 3 Month Office Action*	09798731-0013	0013	US	10/078165	19-Feb-2002	5560	DVM
				Office: CH		1st inventor: GARBER, MELISSA E.			3AS
				Status: Pending	Client Ref:				
Title: NETWORK BASED LEGAL SERVICES SYSTEM									

Thursday, May 01, 2003

Due Date List by Client

Page: 8

From 03-May-2003 To 05-May-2003

Client: 09792902 Sony Corporation

Due Date/ Date Type	Reason for Date	Action Base Date/ Action Type	Client-Matter No	Matter Number	Ctry	Application Number	Filing Date	Confirm No.	Atty's
03-May-2003 Due Date	Postcard - Missing Req.?	13-Dec-2002 Missing Requirements*	09792909-5495	5495	US	10/239542	23-Sep-2002		DVM
Status: Pending				Office: CH			1st inventor: NOGUCHI, TSUTOMU		
Title: REACTOR									
04-May-2003 Reminder	Issue Fee Due In 2 Months	04-Apr-2003 Allowance*	09792909-0326	0326	US	09/561941	01-May-2000	6732	DVM
Status: Allowed				Office: CH			1st inventor: KATO, MASUO		JCE
Title: MOUNTING STRUCTURE OF A SEMICONDUCTOR DEVICE, AND A PROCESS FOR MOUNTING A SEMICONDUCTOR DEVICE ON A MOUNTING SUBSTRATE									
04-May-2003 Due Date	Response To Office Action	04-Feb-2003 3 Month Office Action/SONY*	09792909-4649	4649	US	09/689987	12-Oct-2000		DVM
Status: Pending				Office: CH			1st inventor: NISHIHARA, JUN		JFC
Title: CHEMICAL MECHANICAL POLISHING APPARATUS AND A METHOD OF CHEMICAL MECHANICAL POLISHING USING THE SAME									
04-May-2003 Reminder	1 month to Issue Fee/Drawings	04-Mar-2003 Allowance w/ Drawings*	09792909-4780	4780	US	09/790017	21-Feb-2001	4450	DVM
Status: Allowed				Office: CH					
Title:									
Status: Allowed									
Title:									
Client Ref: S01P0226US00									

From 03-May-2003 To 05-May-2003

Client: 09792909 Sony Corporation

Due Date/ Date Type	Reason for Date	Action Base Date/ Action Type	Client-Matter No	Matter Number	Ctry	Application Number	Filing Date	Confirm No.	Attys
05-May-2003 Due Date	Response to Final OA	05-Feb-2003 Final Office Action/SONY*	09792909-4668	4668	US	09/697473	26-Oct-2000	4504	DVM
	Status: Pending	Client Ref: S00P1315US00		Office: CH		1st inventor: SHIMOUMA, TAKAHASHI			T3B
	Title: MAGNETO-OPTICAL RECORDING MEDIUM								
05-May-2003 Final	Final-Resp After Final/Appeal	05-Nov-2002 Final Office Action/SONY*	09792909-5122	5122	US	09/925153	08-Aug-2001	3081	DVM
	Status: Pending	Client Ref: S01P1473US00		Office: CH		1st inventor: KAWAI, HIROJI			CPR
	Title: INSULATING NITRIDE LAYER AND PROCESS FOR ITS FORMING AND SEMICONDUCTOR DEVICE AND PROCESS FOR ITS PRODUCTION								
05-May-2003 Due Date	Response To Office Action	05-Feb-2003 3 Month Office Action/SONY*	09792909-5132	5132	US	09/943893	31-Aug-2001	2067	DVM
	Status: Pending	Client Ref: S01P1294US00		Office: CH		1st inventor: FUTAMARA, ICHIRO			CPR
	Title: PERSON AUTHENTICATION SYSTEM, PERSON AUTHENTICATION METHOD, INFORMATION PROCESSING APPARATUS, AND PROGRAM PROVIDING MEDIUM								
05-May-2003 Reminder	1 Month To Response To O.A.	05-Mar-2003 3 Month Office Action/SONY*	09792909-5195	5195	US	09/946654	05-Sep-2001	4749	DVM
	Status: Pending	Client Ref: S01P1383US00		Office: CH		1st inventor: NAKAJIMA, HIDEHARU			MQT
	Title: PROCESS FOR PRODUCTION OF THIN FILM, SEMICONDUCTOR THIN FILM, SEMICONDUCTOR DEVICE, PROCESS FOR PRODUCTION OF SEMICONDUCTOR THIN FILM AND APPARATUS FOR PRODUCTION OF SEMICONDUCTOR THIN FILM								

